



IFW/11
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Akram et. al.

Serial No.: 10/620,003

Filed: July 14, 2003

For: METHODS OF FABRICATING
SILICIDE PATTERN STRUCTURES

Confirmation No.: 7478

Examiner: K. Nguyen

Group Art Unit: 2823

Attorney Docket No.: 2269-3521.5US
(97-0985.05/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

May 19, 2004
Date

Rachael M. Harris
Signature

Rachael M. Harris
Name (Type/Print)

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Office Action mailed on February 19, 2004, the three-month shortened statutory period for response to which expires on May 19, 2004.

Amendments to the claims are set forth in the listing of the claims, which begins on page 2 of this paper;

Corrections to the drawings are summarized on page 7 of this paper; annotated drawings and replacement sheets are enclosed herewith; and

Remarks start at page 8 of this paper.

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